

Title (en)
METHOD FOR THE CONTROLLED STORAGE AND RELEASE OF GASES USING AN ELECTROCHEMICALLY PRODUCED CRYSTALLINE, POROUS, ORGANOMETALLIC SKELETON MATERIAL

Title (de)
VERFAHREN ZUR KONTROLLIERTEN SPEICHERUNG UND ABGABE VON GASEN UNTER EINSATZ EINES ELEKTROCHEMISCH HERGESTELLTEN KRISTALLINEN PORÖSEN METALLORGANISCHEN GER STMATERIALS

Title (fr)
PROCEDE POUR STOCKER ET DISTRIBUER DES GAZ DE MANIERE CONTROLEE, AU MOYEN D'UN MATERIAU POREUX CRISTALLIN A CHARPENTE ORGANOMETALLIQUE PRODUIT PAR VOIE ELECTROCHIMIQUE

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Application
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Abstract (en)
[origin: WO2005049484A1] The invention relates to a method for the absorption and/or storage of gases. According to said method, the gas to be stored is brought into contact with an electrochemically produced, organometallic skeleton material in conditions that are favourable for gas absorption. The gas is absorbed by the organometallic skeleton material and the conditions are subsequently modified in such a way that the gas is released.

IPC 8 full level
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Citation (search report)
See references of WO 2005049484A1

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CN103877951A; CN106622150A

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AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HU IE IS IT LI LU MC NL PL PT RO SE SI SK TR

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WO 2005049484 A1 20050602; CA 2544859 A1 20050602; CA 2544859 C 20121002; CA 2546327 A1 20050602; CA 2546327 C 20130903; CN 100537414 C 20090909; CN 1886334 A 20061227; CN 1886536 A 20061227; CN 1886536 B 20101208; DE 10355087 A1 20050609; EP 1687462 A1 20060809; EP 1687462 B1 20190313; EP 1689670 A1 20060816; IS 8517 A 20060622; IS 8518 A 20060622; JP 2007533846 A 20071122; JP 2007534896 A 20071129; JP 2011042881 A 20110303; JP 2011064336 A 20110331; JP 4970043 B2 20120704; JP 5074035 B2 20121114; JP 5349505 B2 20131120; KR 101166590 B1 20120718; KR 101289492 B1 20130724; KR 20060111618 A 20061027; KR 20070013261 A 20070130; MX PA06004620 A 20061214; US 2007227898 A1 20071004; US 2007248852 A1 20071025; US 2011105776 A1 20110505; US 7553352 B2 20090630; US 7968739 B2 20110628; US 8163949 B2 20120424; WO 2005049892 A1 20050602

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